

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

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In re Application of:

Pan et al.

Serial No.: 09/073,494

Filed: May 6, 1998

For: TECHNIQUE FOR ELIMINATION OF  
PITTING ON SILICON SUBSTRATE  
DURING GATE STACK ETCH

Confirmation No.: 9834

Examiner: H. Vu

Group Art Unit: 2811

Attorney Docket No.: 2915.1US (96-149.01)

CERTIFICATE OF MAILING

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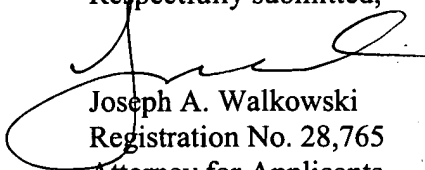
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Sir:

In accordance with 37 C.F.R. § 1.34(b), please recognize the following individual as an associate agent/attorney herein in connection with the above-identified patent application, and with all continuing and divisional applications hereof:

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